Growth and characterization of \( \text{Cu}_2\text{ZnSn(S,Se)_4} \) thin films for solar cells


ABSTRACT

\( \text{Cu}_2\text{ZnSnS_4} \) (CZTS) and \( \text{Cu}_2\text{ZnSnSe_4} \) (CZTSSe) with their band gap energies around 1.45 eV and 1.0 eV, respectively, can be used as the absorber layer in thin film solar cells. By using a mixture of both compounds, \( \text{Cu}_2\text{ZnSn(S,Se)_4} \) (CZTSSe), a band gap tuning may be possible. The latter material has already shown promising results such as solar cell efficiencies up to 10.1%. In this work, CZTSSe thin films were grown in order to study its structure and to establish the best growth precursors. SEM micrographs reveal an open columnar structure for most samples and EDS composition profiling of the cross sections show different selenium gradients. X-ray diffractograms show different shifts of the kesterite/stannite \( \{112\} \) peak, which indicate the presence of CZTSSe. From Raman scattering analysis, it was concluded that all samples had traces of CZTS and CZTSSe. The composition of the CZTSSe layer was estimated using X-ray diffraction and Raman scattering and both results were compared. It was concluded that Se diffused more easily in precursors with ternary Cu-Sn-S phases and metallic Zn than in precursors with ZnS and/or CZTS already formed. It was also showed that a combination of X-ray diffraction and Raman scattering can be used to estimate the ratio of S per Se in CZTSSe samples.

Keywords: 
\( \text{Cu}_2\text{ZnSnSe_4} \) (CZTSe), \( \text{Cu}_2\text{ZnSnS_4} \) (CZTS), \( \text{Cu}_2\text{ZnSn(S,Se)_4} \) (CZTSSe), Thin film solar cells, Kesterites, Chalcogenides

1. Introduction

The development of \( \text{Cu}_2\text{ZnSnS_4} \) (CZTS) and \( \text{Cu}_2\text{ZnSnSe_4} \) (CZTSSe) solar cells have reached efficiencies up to 8.4% [1] and 3.2% [2], respectively. In 2011 Todorov et al., achieved an efficiency of 10.1% by preparing solar cells with an absorber layer of \( \text{Cu}_2\text{ZnSn(S,Se)_4} \) (CZTSSe) [3]. These results heightened the interest in studying films with a mixture of S and Se as a possible replacement for \( \text{CuIn(Ga,Sn)Se_2} \) in thin film solar cells since the use of the expensive and scarce element In is avoided.

CZTSSe should have its band gap energy between the one of CZTS and of CZTS and it should increase with the replacement of Se with S similar to the case of the chalcopyrite semiconductors, \( \text{CuInSe_2} \) and \( \text{CuInS_2} \). This analysis is not straightforward since the exact values of the band gap energy for CZTSe and CZTS are still a debated subject in the literature. For CZTSe, Matsuhashita et al. [4] and Wibowo et al. [5], refer a value between 1.44 eV and 1.56 eV, but Zoppi et al. report values around 0.9 eV [2]. In 2010, Ahn et al. [6] and Sakane et al. [7] reported a band gap energy close to 1 eV. For CZTS, the reported values range from 1.45 eV to 1.66 eV [8–10], but a value closer to 1.5 eV is widely accepted.

Regarding the CZTSSe crystalline structure, it should crystallize in the same structure as CZTS and CzTS, which is either stannite, \( \text{I}-42\text{m group} \) 121, or kesterite, \( \text{I}-4\text{m group} \) 82. The structures are similar, differing only in the ordering of Zn and Cu atoms. Since these atoms have very similar X-ray scattering factors, the identification of the crystalline structure is not possible using conventional X-ray diffraction (XRD) [11] and hereafter we will be considering only the kesterite structure. Concerning the CZTSSe lattice parameters, they should be between the ones of CZTS and of CZTS. Thus, it is expected that in XRD patterns the peaks suffer angular displacements for different atomic ratios of [Se]/[S], for instance the \( \{112\} \) peak, should be between 27.161 and 28.441.

In this study, CZTSSe thin films were prepared and were structurally and morphologically characterized. Different types of precursors were used to allow one to decide which may be the best growth procedure for the formation of CZTSSe. A method to estimate the composition of the CZTSSe layer using both XRD and Raman scattering is studied and discussed.

2. Experimental details

2.1. Sample preparation

For the growth of CZTSSe, precursors containing sulphur were selenised. Different types of films were selenized namely,
metallic/sulphide precursors, ternary Cu₃Sn₄S₉ (CTS) þ Zn/ZnS films and finally CZTS films. In Table 1, the growth details for each sample are presented. Depending on the samples, up to a maximum of five process steps were employed. First, precursors were evaporated and in a second step some of the samples were sulphurized to form CTS. The third step consisted on the deposition of a Zn or ZnS layer by RF magnetron sputtering. The fourth step was a S-diffusion in order to form SnS and finally the fifth step was the selenization to form the CZTSSe layer. Note that not all samples are subjected to the same steps.

In the first step, precursors were sequentially deposited on a Mo coated soda lime glass (SLG) in an evaporation system, with elemental sources of Sn, Cu, Zn and S, therefore allowing the deposition of different sulphides as well as metallic elements. The aimed thicknesses were 807 nm of Cu₃Sn₄S₉ and 810 nm of SnS₂ which should provide a film with a [Cu]/[Sn] value close to 2.

In the second step, a tubular furnace was used [10]. The samples were heated up to a maximum temperature of 525 °C in a N₂ flow rate of 40 ml min⁻¹ at an operating pressure of 10 mbar. This pressure was used in order to minimize Sn losses by evaporation. The sulphur evaporation source was a quartz tube filled with elemental S pellets. The evaporation of sulphur was done at 130 °C. The purpose of this step, which was done prior to the incorporation of Zn, was the formation of a Cu–Sn–S phase, probably cubic Cu₃Sn₄S₉ [12], in order to avoid Sn losses [13,14].

In the third step, either Zn or ZnS was deposited by RF magnetron sputtering. The deposition was performed in an Ar atmosphere at a working pressure of 2 × 10⁻³ mbar. The power densities for Zn and ZnS were 0.41 W cm⁻² and 0.33 W cm⁻², respectively. In situ thickness monitoring was ensured by a quartz crystal monitor and it was aimed to deposit 220 nm of Zn or 570 nm of ZnS. These thicknesses were then confirmed by step profilometry. The fourth step was a sulphurization done in the same conditions as the second step. The final step to form the CZTSSe was a selenization done at a pressure of 1 mbar under an atmosphere of 95% N₂ and 5% H₂ and substrate temperatures of 525 °C [7].

The differences between the samples are precursor layers and on the processing steps prior to the selenization are shown in detailed in Table 1. Sample 1 had metallic layers of Zn and Cu, S was only present during the evaporation of Sn with the following order: SLG/ Mo/Zn/Sn–S/Cu. This sample was only selenized and the remaining steps were skipped. In the case of the other four samples, the second step to form CTS was performed. In sample 2, after the second step elemental Zn was deposited by RF sputtering and CZTS was formed before the selenization. In sample 3 instead of Zn, ZnS was deposited and CZTS was formed before the final selenization. In samples 4 and 5 after the second step ZnS and Zn were deposited, respectively. In both samples, the step to form CZTS was skipped. All samples were selenized under the same conditions.

These samples allowed us to investigate the structural properties of the different thin films and from their comparison to conclude which is the growth procedure most suitable for the growth of CZTSSe.

2.2. Sample characterization

The cross section of the resulting films was analysed by scanning electron microscopy (SEM) and energy dispersive spectrometry (EDS), the system was a SU-70 Hitachi with a Rontec EDS system and the acceleration voltage used was 25 kV. These measurements can both reveal important information about the morphology and chemical composition of the samples. Conventional EDS however is not capable of providing quantification for the content of S due to the fact that the X-ray emission lines of Mo and S are superimposed. The X-ray emission lines are 2.29 keV for the L₁ line of Mo and 2.30 keV for the Kα line of S. One could lower the acceleration voltage so that the Mo layer is not included in the interaction volume, but, in that case, the quantification of Zn and Cu is not ideal since the Cu and Zn L lines nearly overlap around 0.9 keV. Since we are dealing with structured layers, the conditions to perform EDS are also not ideal.

The crystalline structure was studied by X-Ray Diffraction (XRD) with Xpert MPD Philips diffractometer using the Cu Kα line (1.5419 Å). The XRD allows the estimation of the incorporation of Se by looking at the shift of the kesterite (1 1 2) peak. It is known that for CZTSe this peak is centred at 27.161° and for CZTS is centred at 28.441° thus, for CZTSSe, it is expected that the (1 1 2) peak lies between the values above. The expected peak positions mentioned in this paper are taken from the International Centre for Diffraction Data (ICDD).

The films were also analysed by Raman scattering at room temperature using a Jobin-Yvon T64000 micro-Raman spectrometer equipped with a liquid nitrogen cooled silicon CCD and a BX51 Olympus optical microscope. It was used a 100X objective with a 0.95 numerical aperture to excite and collect the Raman signal in the backscattering configuration. The samples were excited with the 532 nm line of a Verdi™ DPSS laser at 2 mW of excitation power on the sample.

3. Results and discussion

The results of the EDS mapping analysis, with the Se counts in the cross sections, are shown in Fig. 1. The cross section SEM micrographs are also shown. This analysis reveals that for all samples, Se was mainly concentrated in a thin layer close to the surface. These results indicate that the Se diffusion was low. For a more thorough analysis other techniques such as SIMS would be needed. The morphology of the resulting CZTSSe films is depicted in Fig. 2. Sample 1 is the most compact one, showing large grains at the top and smaller ones close to the back. The other four samples share a similar columnar structure. In the case of sample 2 just the columnar structure is observed whereas for sample 3 voids are also present. The micrograph for the latter sample, which had ZnS deposited and CZTS was formed, shows a layer at the top of the sample. Sample 4 has the generic structure that all the other samples show but, at the top, it appears to have a different layer. For this sample ZnS was deposited, and CZTS was
not formed. Sample 5 has larger grains than samples 2–4, but the voids are bigger as well.

In order to evaluate the \(\frac{[S]}{[S] + [Se]}\) ratio in the grown thin films and to try to evaluate which phases are present, XRD measurements were performed and the full diffractograms are presented in Fig. 3. All samples show clearly the presence of Mo as well as of a CZT phase. For the CZT phase, only in samples 1 and 5 some of the peaks related to this phase are observed. The identification of CZTS and CZTSe in our samples cannot be rejected by the possible presence of spurious phases like \(Cu_2ZnSn(S,Se)_3\) and \(Zn(S,Se)\). The identification can be done since some of the kesterite peaks that are not superimposed with the peaks of those spurious phases can be seen: (1 0 1) reflection for CZTSe (17.421) or for CZTS (18.241); (1 1 0) reflection for CZTSe (22.081) or for CZTS (23.121); (2 1 1) reflection for CZTSe (36.151) or for CZTS (37.901). Considering the positions of the main peaks for the CZTSe and CZTS phases, namely, for the reflections (1 1 2) at \(25\)–\(28.51\), (2 0 4) at \(45\)–\(47.41\) and (3 1 2)/(1 1 6) at \(54\)–\(56.31\), our samples show the presence of several peaks between the ones for the CZTSe and CZTS phases. Their relative intensities change depending on the film under analysis, which should be related to the growth procedure for each sample. These results allow us to assume the presence of a kesterite \(Cu_2ZnSn(S,Se)_3\) layer in our samples. Since a Se diffusion profile has been observed using the EDS mapping, see Fig. 1, it is very likely that this complex broad peak structure between all the CZTSe and CZTS peaks is from a Se grading from top to bottom in the different films. This diffusion profile along with the strong CZTSe XRD peaks shows that the pure layer of CZTS is located at the bottom part of the samples. The previous peak positions and attributions to the crystallographic direction were correlated using the International Centre for Diffraction Data [15].

Due to the complex task of analysing all the peaks, we will focus on the (1 1 2) peaks since it is the range of angles where the reflection peaks have higher counts and so the analysis is simpler. A zoom of these peaks is shown in Fig. 4. The positions of the (1 1 2) peak for CZTSe at 27.161 and CZTS at 28.441 are shown as vertical lines for reference. All the samples present a strong peak between the CZTSe and CZTS peaks, therefore it will be assumed that this peak is due to a reflection from the (1 1 2) planes of the CZTSe phase. This peak will be referred to as an intermediate peak since it is between the (1 1 2) peaks for CZTS and for CZTSe. Notice that in the ICDD XRD database, there are no entries for mixed S and Se materials as the ones we are dealing with. Assuming that the shift of the CZTSe (1 1 2) peak follows a linear trend between the ones of CZTSe and CZTS, this peak position, \(x\), could be used to estimate the \(\frac{[S]}{[S] + [Se]}\) content of the CZTSe layer. That can be done using a linear interpolation of the position of the (1 1 2) peak in the kesterite structure, which is given by the following equation:

\[
\frac{[S]}{[S] + [Se]} = \frac{A \times x}{27.161 - x};
\]

where \(A\) is a linear factor and takes the value 1.28, which results from the difference between the CZTS and CZTS (1 1 2) peak positions, 28.441 and 27.161, respectively.

Sample 1 shows the well resolved CZTSe (1 1 2) peak, indicating the existence of a layer of CZTS in its structure. This sample is the only one with the intermediate peak closer to the CZTS than to the CZTS. The intermediate peak is also stronger than the CZTS or the CZTSe peaks. It is located at 27.511 which points to a \(\frac{[S]}{[S] + [Se]}\) ratio around 27%. From these observations one can say that this sample is comprised by at least three different layers, CZTS, CZTSe and CZTS. Although this sample had the largest grains, one cannot say that this is due only to the influence of Se since the precursor of this sample was different from remaining ones.

Sample 2 shows a strong CZTSe peak at 27.951 and along with sample 1, this peak is stronger than the CZTS peak. Using Eq. (1), this position points to a CZTSe compound with 60% of S and 40% of Se. Additionally, a shoulder centred at \(27.651\) suggests the presence of a CZTSe phase with a \(\frac{[S]}{[S] + [Se]}\) value around 40%.

The lower intensity ratio between the CZTSe and CZTS (1 1 2) peaks for sample 3 may indicate that there was a smaller incorporation of Se. However, there still is an intermediate peak located at 26.681 which may indicate a CZTSe phase with a ratio \(\frac{[S]}{[S] + [Se]}\) of 40%. A broadening of the CZTS (1 1 2) peak for higher angles is also observed. The origin of this broadening could be related to the presence of a small amount of ZnS for which the
main diffraction peak, (1 1 1), is located at 28.57°. However, no definitive conclusions can be drawn regarding the presence of ZnS due to the small angle difference.

Sample 4 showed in the SEM micrograph a different morphology at the top, which could be ZnS, however, no significant shoulder was visible near the CZTS (1 1 2) peak. The EDS mapping Fig. 2. SEM micrograph of the cross section of the various CZTSSe samples, (a) sample 1, (b) sample 2, (c) sample 3, (d) sample 4 and (e) sample 5. The Mo layer is identified.

Fig. 3. Full XRD diffractograms of samples 1 to 5. The positions of the Mo, CZTS and CZTSe peaks are identified at the bottom of the figure.

Fig. 4. XRD diffractograms centred at the (1 1 2) reflection kesterite peak for samples 1 to 5.
shows a high concentration of Se at the top. Thus, the difference in the morphology could come from the Se incorporation or from the formation of Zn(S,Se) compounds which may give rise to peaks between the ones of CZTSe and CZTS. In this sample a peak can be found at 27.71 which could be from a CZTSSe phase with a ratio [S]/([Se]+[S]) of 40%.

As mentioned before, sample 5 has a peak at 27.161 which indicates that CZTSe is present. From all the studied samples, this is the one that appears to have a smoother gradient of Se since the intensity of the peaks lowers continuously from the CZTSe to the CZTSSe (1 1 2) peak. There are two visible intermediate peaks, located at 27.391 and 27.921 which correspond to a ratio [S]/([Se]+[S]) of 17% and 60%, respectively. However, the EDS results for this sample do not confirm the presence of a Se gradient.

Raman scattering measurements on the cross sections would allow a more detailed discussion regarding the origin of the XRD peaks. However, such measurements are hard to perform due to the large size of the laser spot, which is approximately 1 mm wide, and due to the difficulty in correctly focusing it. Instead, surface Raman scattering analysis was performed since additional information on possible secondary phases can be obtained. According to the literature, the main peaks of the discussed phases are found at: 194–197 cm\(^{-1}\) for CZTSe [16,17], 250 cm\(^{-1}\) for ZnSe [18], 260 cm\(^{-1}\) for Cu$_2$–Se [19], 334–338 cm\(^{-1}\) for CZTS [12], 350 cm\(^{-1}\) for ZnS [20] and 475 cm\(^{-1}\) for Cu$_2$–S [12]. In Fig. 5, the Raman scattering spectra is presented and the literature values for the peak positions of CZTSe, Cu$_2$–Se and CZTS are represented as vertical lines. All samples show a peak at 331 cm\(^{-1}\) which is attributed to the CZTS A1 mode. This peak appears shifted to lower energies with respect to the reported values, 338 cm\(^{-1}\). This is not caused by a calibration problem since most of the samples show a Cu$_2$–Se peak at 262 cm\(^{-1}\), which is in accordance with the literature. The exact same shift to lower energies of the CZTSSe peak for all the samples is not fully understood, it may be due to a gradient in strain [21], due to a gradient of crystal quality in the layers [22] or even heating of the samples [23]. This peak is strongly related to CZTS since its presence was confirmed by XRD measurements, as discussed previously. Furthermore no other secondary phases are known to have a Raman scattering peak at the referred position, 331 cm\(^{-1}\). According to Grossberg et al. [24], the A1 vibration mode of the CZTS shifts to lower energies with the substitution of S by Se, but for all samples the peak is located at the same value, thus the shift is not due to different Se contents but to other reason. However, in this study we are dealing with graded films whereas Grossberg et al. [24] analysed bulk homogenous samples. For all samples one or more peaks are present in the spectra in the range 200–250 cm\(^{-1}\). According to the results of Grossberg et al. [24] this vibration mode, an A1 mode, also shifts linearly with different replacement values of Se per S. Thus, it can be assumed that the shifting of these peaks is due to a replacement of Se atoms by S atoms. Given the values of the CZTSe A1 vibration mode published by Grossberg et al. [24], where it was presented a linear shift of this peak between 196 cm\(^{-1}\) and 226 cm\(^{-1}\) for samples with a ratio [S]/([Se]+[S]) from 0% to 75%, it is possible to correlate the composition of the analysed sample with its Raman peak position, Z similar to what was done with XRD results, in this work, by using a linear interpolation:

\[ Z = 0.76 \times S + 196.8 - 40 \]

where 196 is the peak position for a ratio of 0% and 40 is the linear constant that fits to Grossberg et al. results.

Therefore, and considering the XRD results, the peaks found between 196 cm\(^{-1}\) and 226 cm\(^{-1}\) can be associated with a CZTSSe phase.

Sample 1 shows the strongest CZTSSe peak, located around 204 cm\(^{-1}\) and along with sample 5 shows a CZTSSe peak stronger than the CZTS peak. This, however, does not mean that the sample has a higher content of CZTSSe compared to CZTS since the Raman scattering efficiency of the different materials may not be the same.

Samples 2 and 3, present a pronounced shoulder at 330 cm\(^{-1}\), close to the CZTS main peak, at higher energies. As the main peak of ZnS is around 350 cm\(^{-1}\), these shoulders may indicate that these samples have traces of ZnS, but since the peaks are quite broad, it is difficult to resolve Lorentz curves to try to figure out hidden peaks [25]. In XRD measurements, sample 3 was the one where the CZTS (1 1 2) peak, located at 28.441, presented a higher shift in the direction of the (1 1 1) ZnS peak at 28.571. So, XRD and Raman data suggest the presence of ZnS in sample 3.

Most of the samples show the 262 cm\(^{-1}\) peak of Cu$_2$–Se and sample 5 is the one where this peak has the highest relative intensity. This identification also explains the XRD peak found at 27.921 since CuSe has a XRD maximum located at 28.021. No traces of Cu$_2$–S were found. The presence of Cu$_2$–Se and Se at the surface, as revealed by the EDS measurements, suggest that the film is rich at the surface. The Raman peaks shown are broad which may reveal a poor crystalline quality. Regarding the presence of Zn(S,Se) in samples 3 and 4, both had a layer of ZnSe deposited and showed a layer with different morphology on top of the processed film. However this was not confirmed since at the Raman ZnSe peak position, 250 cm\(^{-1}\), nothing is found and the presence of ZnS was already discussed. A better look at the different layers would be possible by either using different excitation wavelengths [25], or by using a UV laser along with sputtering to perform an in-depth Raman [26].

With the information from the XRD and the Raman a comparison of the compositions of the CZTSSe phases obtained by the two methods was done and is presented in Table 2. For samples 1, 3, 4 and 5 the composition of the CZTSSe phases found by XRD and Raman are in good agreement. For sample 2, there are two intermediate XRD peaks and thereby two compositions can be estimated, 40% and 60% for the ratio [S]/([Se]+[S]). However, the Raman scattering shows a structure of peaks between 197 cm\(^{-1}\) and 230 cm\(^{-1}\) which would correspond to a value of [S]/([Se]+[S]) between 0 and 80. Considering both results, one can say that probably there are several CZTSSe phases, which is similar to say that there is a strong Se grading. The errors of the estimation of [S]/([Se]+[S]) depend mostly on the broadening of the peaks for both techniques. Since the source of this broadening

![Fig. 5. Raman scattering analysis of the CZTSSe thin films. The vertical lines are guides to the eye corresponding to the main Raman scattering peaks of the referred structures.](image-url)
is coming from a graded structure, and our estimation is based on a single layer, they also depend mainly on the Se grading for each sample and less on the measuring technique itself. Therefore, a quantification of an uncertainty is hard.

From these structural and morphological analyses, there were two samples that presented more distinctive results: samples 1 and 5. The sample with the best morphology was sample 1 and it also revealed a strong intermediate peak closer to the CZTSe peak, both in XRD and in the Raman scattering analysis. It is possible that this sample had the highest Se content, due to the presence of the XRD CZTSe peak and to the fact that the XRD CZTSSe peak is located closer to the CZTSe position. The diffractionogram of sample 5 shows a continuum of peaks between the CZTSe and CZTS (1 1 2) maxima, which suggests that it has the smoothest Se grading among all samples. In the Raman scattering analysis, the sample exhibited a strong Cu$_2$–Se peak, which explains one of the intermediate peaks of the XRD, but it also presented an intense CZTSSe peak when compared to the other samples. The fact that CZTS was not formed prior to the selenization and Zn was in its metallic form, was probably a determining factor in allowing the diffusion of Se into the film. Regarding the two samples where CZTS was formed before the selenization, samples 2 and 3, they both presented strong XRD CZTS peaks and it is even likely that sample 3 had a ZnS layer. From a previous work [27], we already knew that preparing the precursors with a ZnS layer without the presence of H$_2$, leads to CZTS films with some ZnS on top. In the present work, H$_2$ was used during the selenization step instead of the sulphurization step which may have influenced the results; moreover, the evidences of the ZnS layer are not as strong as in the previously mentioned work. Sample 4, the one where CZTS was not formed and ZnS was deposited, showed a Se ratio close to 50%, small traces of Cu$_2$–Se and no traces of ZnS were found.

4. Conclusions

In this work, we have studied the incorporation of Se into different samples to evaluate the best route for the formation of CZTSSe thin films. It was evidenced that in samples where ZnS or CZTS was formed prior to the selenization, the incorporation of Se was smaller than in precursors with metallic layers or in precursors where there was only CZTS and elemental Zn. It was proved that in all samples, a Se graded structure was produced with different ratios of incorporation of Se. If one intends to have a large amount of Se introduced in these films, without the appearance of secondary phases, then the use of precursors with Mo/Zn/SnS/Cu or Mo/SnS/CuS/ZnS without the formation of CZTS are the most suitable choices.

It was also shown that the XRD and Raman scattering peak positions shift with the quantity of Se incorporated and a comparison of the estimated composition determined by XRD and Raman scattering of the CZTSSe layer was done. This is in accordance with other published work [28]. Using the equations developed in this paper, the two techniques can be used to estimate the quantity of Se and S, something that is not possible to do using conventional EDS due to the overlapping of the Mo L$_\alpha$ and S K$_\alpha$ emissions.

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[15] International Centre for Diffraction Data; Cu, Zn, Sn, 04-005-0388, Cu$_2$ZnSnS$_4$, 04-010-6295.


